

On-Chip Sub-Picometer Continuous Wavelength Fiber-Bragg-Grating Interrogator

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Abstract: Miniaturized fiber-Bragg-grating (FBG) interrogators are of interest for applications in the areas where weight and size controlling is important, e.g., airplanes and aerospace or in-situ monitoring. An ultra-compact high-precision on-chip interrogator is proposed based on a tailored arrayed waveguide grating (AWG) on a silicon-on-insulator (SOI) platform. The on-chip interrogator enables continuous wavelength interrogation from 1544 nm to 1568 nm with the wavelength accuracy of less than 1 pm [the root-mean-square error (RMSE) is 0.73 pm] over the whole wavelength range. The chip loss is less than 5 dB. The 1×16 AWG is optimized to achieve a large bandwidth and a low noise level at each channel, and the FBG reflection peaks can be detected by multiple output channels of the AWG. The fabricated AWG is utilized to interrogate FBG sensors through the center of gravity (CoG) algorithm. The validation of an on-chip FBG interrogator that works with sub-picometer wavelength accuracy in a broad wavelength range shows large potential for applications in miniaturized fiber optic sensing systems.

Keywords: Fiber optic sensing; on-chip interrogator; arrayed waveguide grating; center of gravity

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1. Introduction

The fiber-Bragg-grating (FBG) method is one of the well-known optical fiber sensing methods for strain and temperature measurement, which has the characteristics of the small size, immunity to electromagnetic interference, corrosion resistance, and high reliability. FBG sensors have been widely used for structural health monitoring [1], energy security [2, 3], aerospace [4], robots, and medical devices [5–7]. The FBG interrogator is a device that analyzes the data of the FBG by monitoring the

central wavelength change. Several approaches for FBG interrogation have been reported in the literature, such as the scanning Fabry-Pérot (FP) cavity [8, 9], tunable lasers [10, 11], and volume phase grating-based spectrometers [12, 13]. However, most traditional interrogators usually suffer from the high price and bulky volume, which limits their applications in some emerging fields, such as unmanned aerial vehicle (UAV) monitoring, lithium-ion battery status monitoring [14], and in-situ three-dimensional (3D) shape sensing [15–18]. On-chip FBG interrogators based on the

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photonic integrated circuit (PIC) technology have been extensively studied recently due to its advantages of the small size and low power consumption.

According to the employed architectures, the structures of on-chip FBG interrogators can be mainly categorized into four types, including the Mach-Zehnder interferometer (MZI) [19–22], micro-ring resonator (MRR) [23–26], arrayed waveguide grating (AWG) [27–35], and tunable semiconductor laser [36]. Among them, the wavelength accuracy, wavelength range, size of interrogator, and number of FBG sensors are difficult to be satisfied simultaneously. For example, the MZI architecture-based FBG interrogator has high wavelength accuracy, but only a limited number of FBG sensors can be interrogated. The interrogators based on the micro-ring resonator (MRR) architecture can be very small; however, the wavelength range and wavelength accuracy are limited. The tunable semiconductor laser architecture has the advantage of high accuracy, while the wavelength range is limited by the gain range of the laser.

On-chip FBG interrogators based on the tailored AWG are promising to achieve the high wavelength accuracy, large wavelength range, compact size, and multi-sensors interrogated, simultaneously. However, until now, the absolute wavelength accuracy of AWG-based on-chip interrogators is still worse than that of the traditional interrogators with the bulky volume. In this paper, we propose a novel on-chip FBG interrogator with high wavelength accuracy continuously working in a broad measurement range. Thanks to the optimized layout design of the AWG, we successfully fabricated a 1×16 tailored AWG with the chip loss less than 5 dB and the low noise level of -27 dB. Using the tailored AWG to interrogate the FBG sensor, we are able to achieve the comparable high absolute wavelength accuracy [the root-mean-square error (RMSE) is 0.73 pm] in a large measurement range (24 nm). This paper

validates an on-chip FBG interrogator that works with sub-picometer absolute wavelength accuracy.

2. Methods

2.1 Principle

The proposed on-chip interrogator is based on a tailored AWG. A typical AWG is composed of two free propagation regions (FPR1 and FPR2) connecting each together by an array of waveguides [see Fig. 1(a)]. Different from the conventional AWG designed for wavelength division multiplexing based communication applications where the low adjacent channel crosstalk (an adequate bandwidth) is preferred, the AWG proposed in this paper has an intentionally large bandwidth at each channel, which allows the FBG peak to produce a measurable output signal in multiple AWG channels. The channel bandwidth of the AWG can be calculated by the overlap of the input field profile and mode profile of the output waveguide at the image plane, and determined by the input and output waveguide mode diameter and the pitch between output waveguides [37]. Hence, in order to obtain a desired crosstalk between AWG output channels, we, on one hand, reduce the pitch between adjacent output waveguides, and on the other hand, increase the entrance width of the input waveguide at the object plane. Based on the principle of the center of gravity (CoG) algorithm and according to the measured optical power P_i (λ_{FBG}) and the central wavelength λ_i at the i th output channel of AWG, the peak wavelength λ_{FBG} of the FBG can be derived using the following equation:

$$\lambda_{\text{FBG}} = \frac{\sum P_i(\lambda_{\text{FBG}}) \lambda_i}{\sum P_i(\lambda_{\text{FBG}})}. \quad (1)$$

Figure 1(b) also shows the schematic diagram of deriving λ_{FBG} using the tailored AWG. Due to fabrication imperfections, such as the waveguide thickness and width fluctuation, the real transmission spectrum of the designed AWG is slightly different from the ideal Gaussian function, which causes deviations between the calculated

FBG wavelength using the CoG algorithm and the actual FBG central wavelength. Hence, the absolute wavelength accuracy is decreased. In order to tackle this issue, we perform the polynomial curve fitting combined with the sum of the sine curve fitting based on the testing data to improve the absolute wavelength accuracy of the on-chip FBG interrogator.

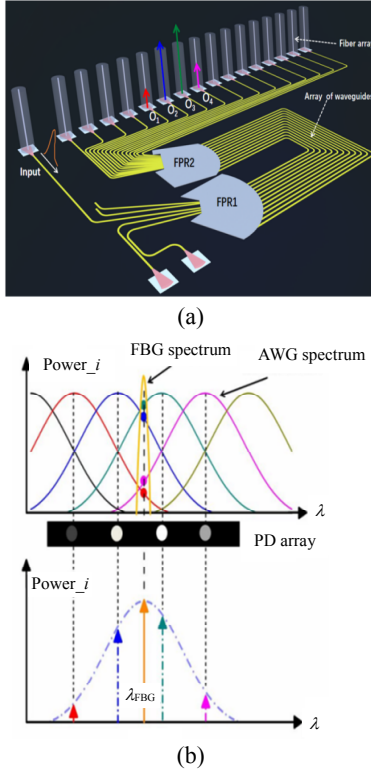


Fig. 1 Principle of the on-chip FBG interrogator: (a) schematic diagram of the proposed AWG and (b) energy of the FBG peak is distributed into multiple channels of AWG and the peak wavelength is derived by the CoG algorithm (PD array stands for photodetector array).

2.2 AWG design

A 1×16 AWG with the output wavelength spacing $\Delta\lambda = 1.6$ nm is designed on a standard silicon-on-insulator (SOI) wafer with the top silicon layer thickness of 220 nm. As mentioned in the previous section, we reduce the pitch d_o between the adjacent output waveguides and increase the entrance width w_i of the input waveguide to achieve a large bandwidth at each channel. Considering the facts that d_o cannot be reduced indefinitely due to the fabrication requirement and the extra mode

mismatch loss between input and output waveguides, which increases with the width of the input waveguide, in order to have a good tradeoff, we set $d_o = 1.2$ μm and $w_i = 5$ μm . In order to reduce the coupling between the adjacent output waveguides, a deeply etched linear taper waveguide with the entrance width of 0.8 μm and exit width of 0.43 μm is introduced between each output waveguide and FPR2. According to our previous research [38], the performance of the AWG is directly related to the footprint of the phase region consisting of FPR1 (FPR2) and array waveguides, which is determined by the radius R of FPR1 (FPR2). Based on (1), R can be derived as

$$R = d_o d_a \frac{\lambda_0}{\Delta\lambda} \cdot \frac{n_a}{n_{ga} \Delta L + n_{gs} d_a \sin\theta_i} \quad (2)$$

where n_{gs} and n_{ga} are the group indices of FPR1 (FPR2) and the array waveguide, respectively. d_a is the pitch between adjacent array waveguides, λ_0 is the designed central wavelength, and $\Delta\lambda$ is the output wavelength spacing. Usually, $n_{gs} d_a \sin\theta_i \ll n_{ga} \Delta L$, and hence, R is mainly proportional to the product of $d_o d_a$ for the given $\Delta\lambda$, indicating that d_o and d_a should be appropriately chosen to decrease R .

In addition, in order to reduce the sensitivity of the effective index to width fluctuation originating from fabrication imperfections, each waveguide in the phased array is composed of the broad straight waveguide with the width of 800 nm, the narrow single-mode bending waveguide with the width of 430 nm, and adiabatic tapers with the length of 5 μm to connect the broad and narrow waveguides. At the same time, the two FPRs (FPR1 and FPR2) are parallelly arranged with a tilt angle to eliminate the phase error resulting from the effective index difference between curved and straight waveguides. A mode converter based on a shallowly etched multimode interference coupler with the width of 2.3 μm and the length of 2.7 μm connecting to a parabolic taper with the length of 3.5 μm is inserted between the FPR1 (FPR2) and array waveguide to reduce the mode transition loss from the FPR1

(FPR2) to the phased array. Using 3D-finite difference time domain (3D-FDTD) simulation, we obtain that the mode conversion loss is as small as 0.32 dB at the wavelength range of 1500 nm to 1600 nm between the FPR1 (FPR2) and array waveguide. Table 1 summarizes the main design parameters of the 1×16 AWG. The free spectral range (FSR) is 29.569 nm, which means that 87% of the FSR is occupied in the micro-interrogator design. The footprint of the designed micro-interrogator including all input and output waveguides is only $0.5 \times 2.0 \text{ mm}^2$.

Table 1 Main design parameters of the 1×16 AWG.

Parameter	Quantity
Central wavelength (nm)	1560.00
Diffraction order	36
Free spectral range (FSR) (nm)	29.569
Radius of FPR (μm)	99.9
Delay length ΔL (μm)	20.948
Number of arrayed waveguides	31
Pitch d_o between adjacent output waveguides (μm)	1.2
Exit (entrance) width w_i (w_o) of input (output) waveguide on the Rowland circle (μm)	5 (0.8)
Footprint of phase region (μm^2)	320×410

2.3 Fabrication and characterization

The proposed on-chip interrogator is fabricated on a 200-mm silicon on insulator (SOI) wafer with the 220-nm thick top silicon layer and 2- μm thick buried oxide layer (BOX). The patterns are defined using 193 nm photolithography and a double etch process. First, the interrogator is defined into a layer of photo-resist (PR) and transferred into the SiO_2 hard mask by means of inductively coupled plasma etching. Then, a shallow 70-nm etch is used to define the grating couplers and shallowly-etched multimode interference coupler (MMI) based mode converters, followed by the 150-nm etch to form channel waveguides. At last, an upper-cladding layer of SiO_2 with the thickness of 2 μm is deposited by using the plasma enhanced chemical vapor deposition (PECVD). Optical microscope images of the fabricated interrogator are shown in Fig. 2(a).

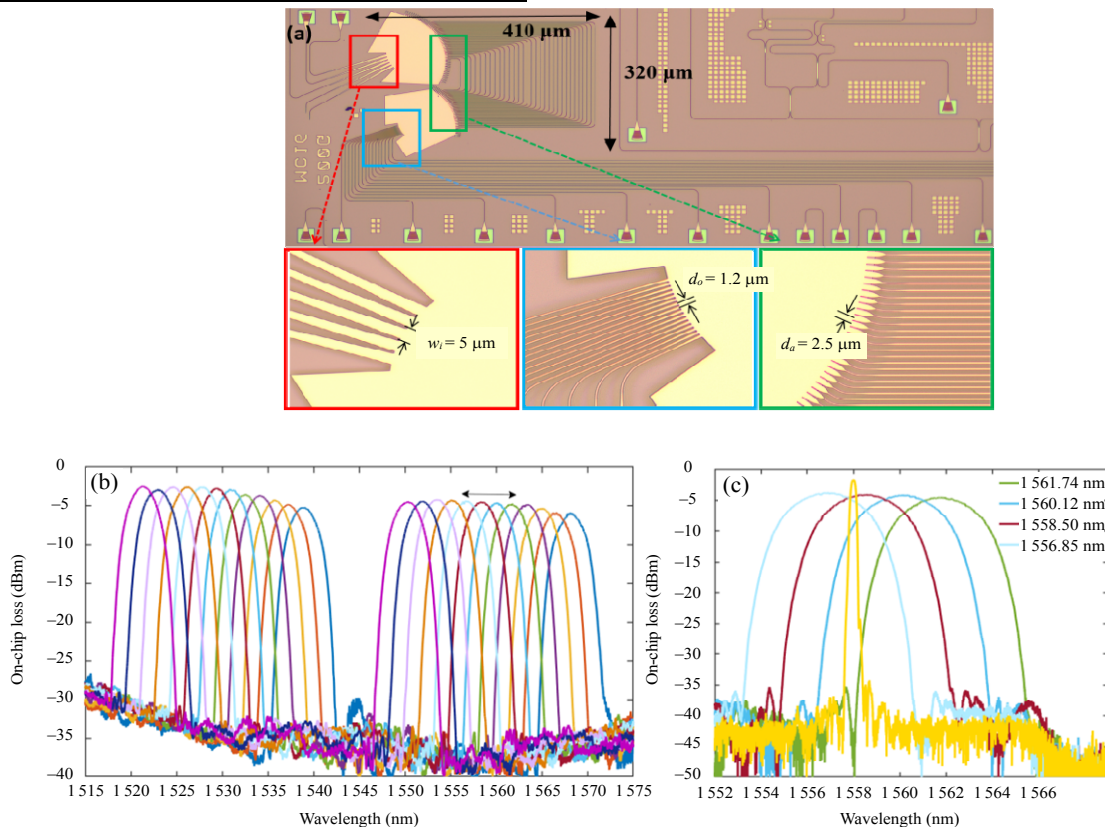


Fig. 2 Characterization of the fabricated on-chip interrogator: (a) microscopic image of the fabricated 1×16 AWG, (b) full spectra of AWG output ports (due to limitations of the test system, only 12 of the 16 channels are tested and shown), and (c) spectral response of 4 AWG channels used for FBG interrogation (the central wavelengths of 4 AWG channels are 1556.85 nm, 1558.50 nm, 1560.12 nm, and 1561.74 nm, respectively, and the central wavelength of the FBG is 1558.00 nm at room temperature).

Light from a tunable laser source (Agilent, 81608A) firstly passes through a fiber polarization controller, which tunes the polarization direction of the input light to the transverse electric (TE) polarization and then is coupled into the input port of the AWG interrogator via a grating coupler. After propagating through the AWG, the light is coupled out using an array of grating couplers. In order to facilitate the testing, the input/output grating couplers are designed with the 127- μm pitch on the same side for coupling to the 1×18 fiber arrays, which are directly connected to a multi-channel optical power meter (Agilent, N7744C). By scanning the wavelength of the tunable laser from 1500 nm to 1600 nm, the optical power at each output port is collected to obtain the spectral response of the AWG, as shown in Fig. 2(b), where the spectral responses of two diffraction orders are given. Figure 2(c) shows the spectral response of 4 AWG channels used for FBG interrogation, as included in the black double arrow in Fig. 2(b). It is known that the noise level at each channel is below -27 dB due to the optimized layout design of the phase region in the current AWG design. The on-chip loss varies from -6 dB to -4.3 dB.

2.4 Experimental set-up

The experimental set-up used to characterize the

on-chip FBG interrogator is shown in Fig. 3(a). Broadband light emitted from a super luminescent diode (central wavelength = 1550 nm and 3-dB bandwidth = 50 nm) is coupled to the FBG sensor through an optical circulator. The FBG sensor under test is written by the femtosecond laser and mounted on a heating platform. Light reflected from the FBG sensor is transmitted through the optical circulator again and split into two equal parts. One is coupled to a commercial interrogator as a reference, and the other is coupled to the on-chip FBG interrogator. Output power at all output channels of the AWG is simultaneously detected by the multi-channel optical power meter, which converts the detected optical power into electrical signals. Finally, the obtained electrical signals are employed to derive the central wavelength of the FBG reflection peak using the CoG algorithm. The on-chip FBG interrogator is mounted on a thermal electric cooler (TEC) to stabilize the operating temperature to eliminate the ambient temperature change induced wavelength shift of the AWG spectral response during the measurement [see Fig. 3(c)]. The absolute wavelength accuracy of the on-chip interrogator is analyzed through comparing the FBG wavelength (FBG-w) recorded by the commercial interrogator and by our packaged miniature interrogator [see Fig. 3(d)].

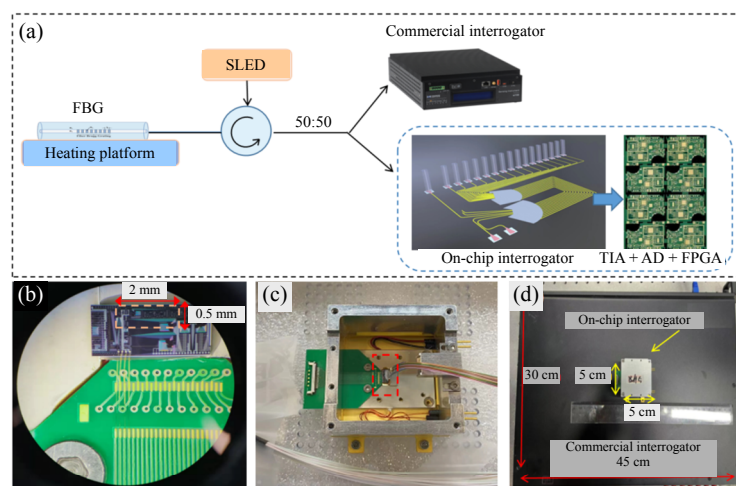


Fig. 3 Experimental set-up to characterize the performance of the FBG interrogator: (a) a sketch of the experimental set-up (SLED is a super luminescent diode, TIA is a trans-impedance amplifier, AD is an analog-to-digital converter, and FPGA is a field programmable gate array), (b) microscope picture of the interrogator chip, (c) interrogator chip mounted on a TEC, and (d) size comparison of packaged on-chip interrogator and commercial interrogator.

3. Results and discussion

3.1 Single FBG interrogation based on CoG algorithm

In order to evaluate the performance of the proposed on-chip FBG interrogator, the following simulation and experiment are carried out. The central wavelength and 3-dB bandwidth of the FBG sensor at room temperature are 1558.0 nm and 0.24 nm. The central wavelength of the FBG reflection spectrum varies by controlling the temperature of the FBG sensor. The central wavelengths of the 4 employed AWG channels are 1556.85 nm, 1558.50 nm, 1560.12 nm, and 1561.74 nm, respectively [see Fig. 2(c)].

First, we theoretically analyze the wavelength accuracy of the fabricated on-chip interrogator based on the measured spectral responses of the AWG and FBG. The AWG spectra and FBG spectra as shown in Fig. 2(c) are imported to the commercial software OptiSystem 13.0. A white light source is used as the broadband light source in the simulation. By tuning the central wavelength of the FBG from 1558.50 nm to 1560.10 nm, the CoG wavelength (CoG-w) is derived through the detected power from the 4 AWG output channels [see Fig. 4(a)] using (1). The relationship between the calculated CoG wavelength denoted as CoG-w and the real FBG wavelength denoted as FBG-w is shown in Fig. 4(b) with the black cross marker. It is known that the CoG-w differs slightly from the FBG-w, which can be attributed to the facts that the actual spectral response of the AWG is not perfect due to imperfect fabrications and the CoG algorithm gives exact results only if all the AWG channels have exactly the same spectral shape and constant channel spacing. A “correction” function applying a polynomial curve fitting between CoG-w and FBG-w is also given in Fig. 4(b) with the sky-blue line. Using the “correction” function, we can obtain the “corrected” FBG-w. The wavelength deviation

of FBG-w and “corrected” FBG-w can be represented with a “sum of sine” function fitting as shown in Fig. 4(b) with the red line. The absolute wavelength accuracy of the on-chip interrogator is evaluated as the error of “sum of sine” function fitting as shown in Fig. 4(c) with the black stem. It is known that the root mean square error (RMSE) of the absolute wavelength accuracy of 0.31 pm is successfully achieved over the whole wavelength range.

Then, the following experiment has been carried out to validate this on-chip interrogator. A controlled temperature is applied to the FBG sensor under test by means of a heating platform, and the detected power at AWG output channels is recorded by the multi-channel optical power meter. At the same time, the wavelength of the FBG peak is measured using the commercial interrogator. By changing the temperature of the FBG from 70 °C to 180 °C, the central wavelength of the FBG shifts from 1558.50 nm to 1560.10 nm and is recorded as the FBG-w by the commercial interrogator. The CoG-w is also calculated based on the detected power from the multi-channel optical power meter as shown in Fig. 4(d). The relationship between the calculated CoG-w and FBG-w is shown in Fig. 4(e). Using the same data processing method, the polynomial curve fitting and the sum of the sine function fitting to the experimental data are performed as shown in Fig. 4(e), respectively. One can see from Fig. 4(f) that the absolute wavelength accuracy is less than 1 pm (RMSE = 0.73 pm) over the whole wavelength range. The difference between the simulated and experimental results can be attributed to the fact that the heating speed of the FBG is so fast, especially between 70 °C and 110 °C corresponding to the central wavelength changing from 1558.50 nm to 1559.08 nm, so that the data acquisitions of the commercial interrogator and multi-channel power meter are not fully synchronous.

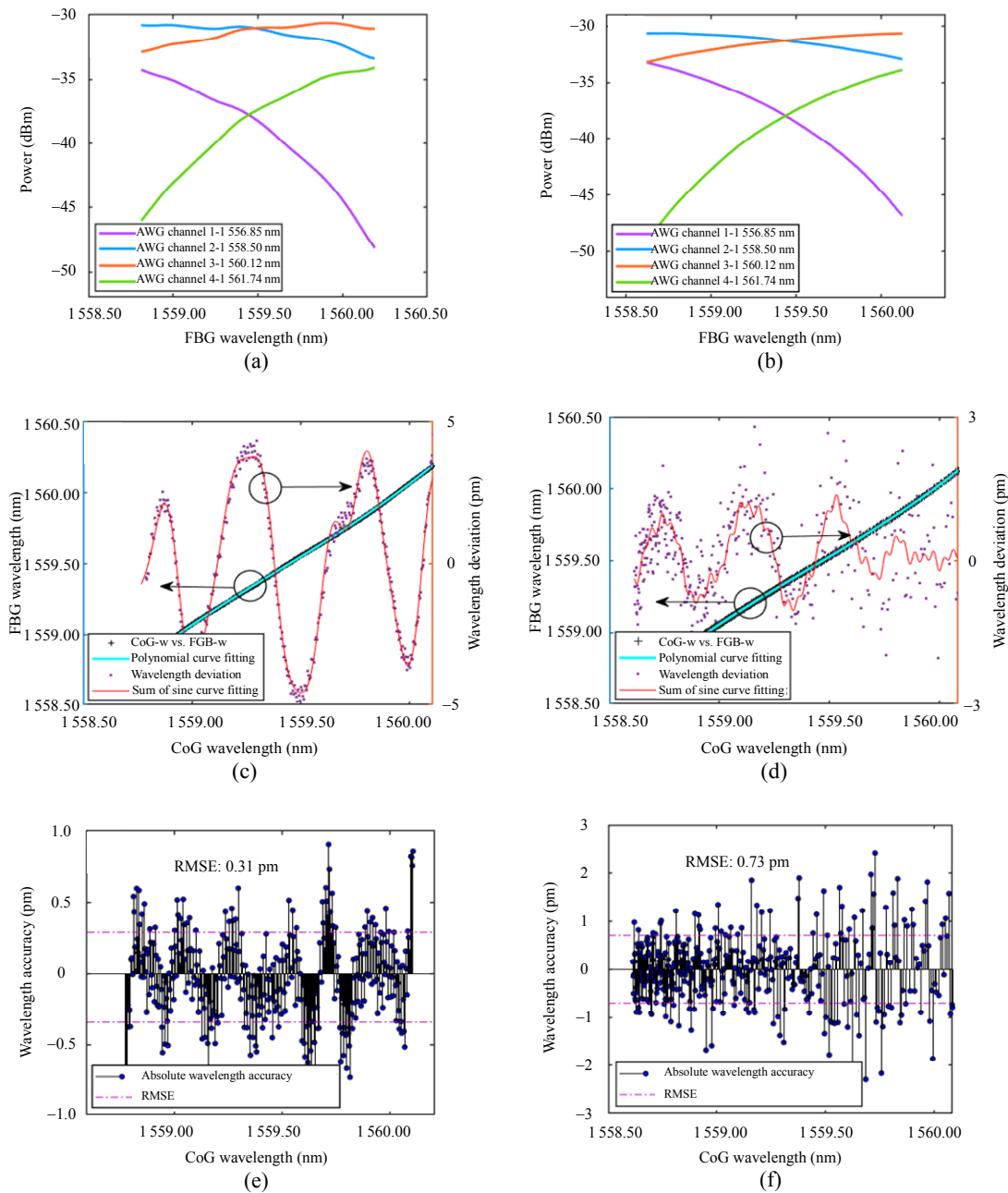


Fig. 4 Simulated and experimental performance of the FBG interrogator: (a) and (b) simulated results and experiment results: detected power from the 4 AWG output channels; (c) and (d) simulated results and experimental results: the relationship of FBG-w and CoG-w (black cross), the “correction” function between CoG-w and FBG-w using the polynomial curve fitting (sky blue line), the wavelength deviation of FBG-w and “corrected” FBG-w (purple dot), and the “sum of sine” function fitting (red line); (e) and (f) simulated results and experimental results: the absolute wavelength accuracy of the on-chip interrogator (black stem).

3.2 Continuous wavelength interrogation based on CoG algorithm

Subsequently, we extend the operating wavelength range of the FBG to validate the ability

of continuous interrogation of the fabricated interrogator. Since 4 AWG channels in the proposed interrogator are employed to the interrogate single FBG with the dynamic range of 1.6 nm, which is equal to the AWG channel spacing. If we

dynamically select 4 adjacent channels of the 16 channels of the AWG, it is possible to achieve the continuous wavelength interrogation for one FBG sensor across the whole AWG spectrum range. We analyze the performance of 9.60 nm continuous wavelength interrogation between 1551.80 nm and 1561.40 nm as shown in Fig. 5(a) where 9 AWG channels are utilized to realize 6 different groups of wavelength interrogation represented by different colors and each group consists of 4 consecutive AWG channels. Figure 5(b) shows the relationship of FBG-w and CoG-w in each group. Using the

same “correction” function of the polynomial curve fitting as in Fig. 4, we get the wavelength deviation of FBG-w and “corrected” FBG-w as shown in Fig. 5(c). The difference in the deviation of each group stems from the fact that the spectral shapes of AWG channels are slightly different from each other. Then, the deviation is calibrated using the sum of the sine curve fitting. The calibration results are employed to estimate the absolute wavelength accuracy as shown in Fig. 5(d). The achieved absolute wavelength accuracy is less than 1 pm over the whole wavelength range.

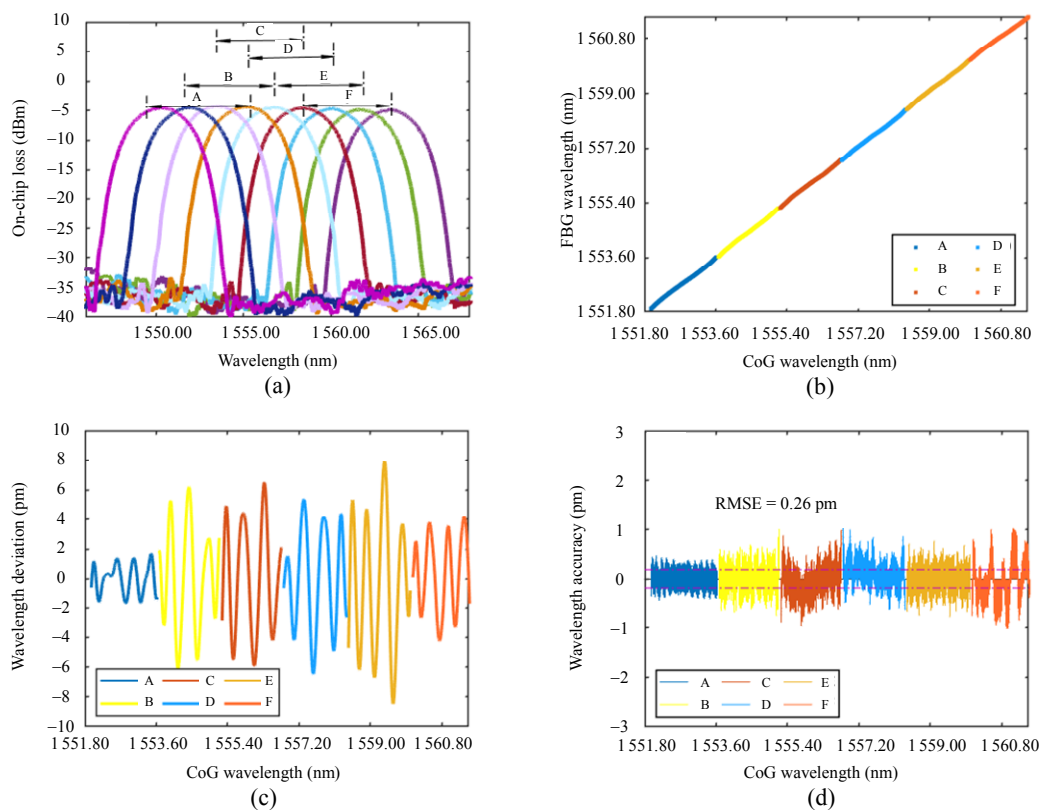


Fig. 5 Continuous wavelength interrogation: (a) schematic diagram of continuous wavelength interrogation based on the CoG algorithm, (b) relationship of FBG-w and CoG-w of 6 groups (A, B, C, D, E, and F) between 1551.80 nm and 1561.40 nm, (c) error analysis of the wavelength calibration using the polynomial curve fitting and the sum of the sine curve fitting, and (d) absolute wavelength accuracy of 6 groups applying continuous wavelength interrogation.

3.3 Multiple FBGs interrogation

Here, we demonstrate the ability of the on-chip interrogator to simultaneously interrogate multiple FBGs. Due to the limited number of output channels of the fabricated AWG, we use two FBGs as an example. Each FBG is assigned with 4 AWG

channels in the experiment. In order to differentiate from the FBG sensor used in Subsection 3.1, the peak wavelengths of these two FBGs are around 1528 nm and 1534 nm at room temperature, respectively, as shown in Fig. 6(a), and the spectral response of the AWG working at another diffraction order is also given. When the wavelength difference

of adjacent FBG sensors is less than the dynamic wavelength range, the interference between two sensors will cause errors and affect the accuracy. So, there is a minimum wavelength interval of FBGs, and we must ensure the wavelength difference of FBGs is larger than the minimum wavelength interval. In our design, the minimum wavelength interval of FBGs is 4.8 nm. By controlling the working temperature of these two FBGs, the central

wavelength of the FBG1 in Group1 changes from 1528.30 nm to 1529.60 nm, while the central wavelength of the FBG2 in Group2 varies from 1534.40 nm to 1535.90 nm. The same data processing and analysis as introduced in subsection 3.1 are conducted. It is known from Figs. 6(b)–6(c) that the absolute wavelength accuracy is less than 1 pm for both FBG sensors, agreeing well with that achieved in Subsection 3.1.

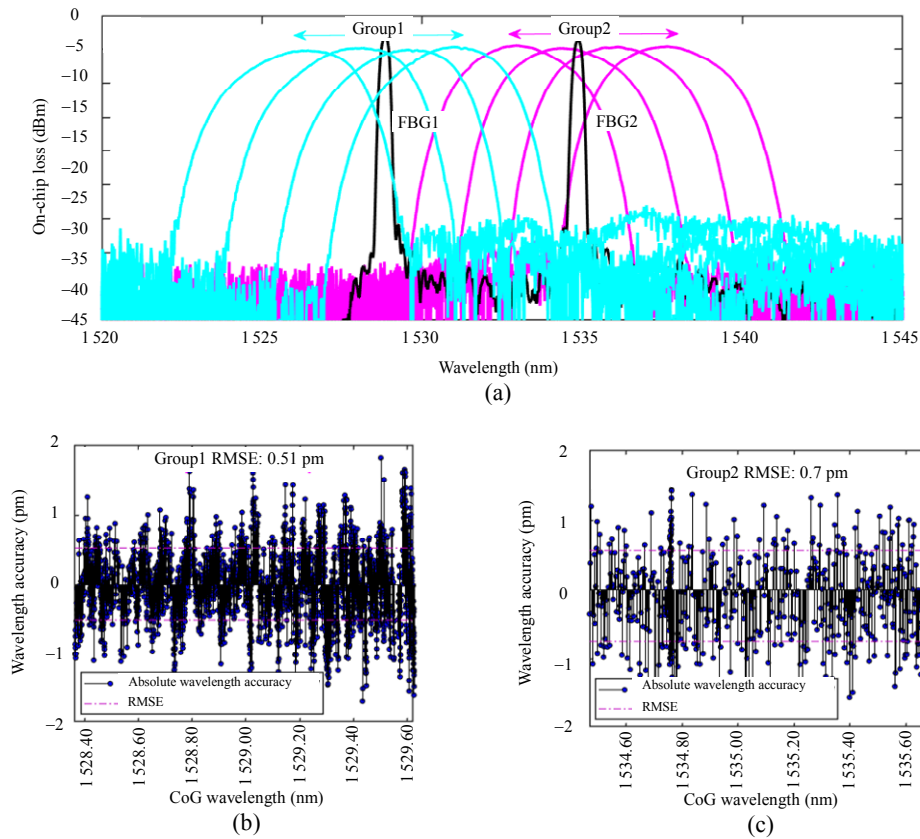


Fig. 6 Simultaneous interrogation of two FBGs: (a) measured spectral response of FBG sensors (FBG1 and FBG2) and two group AWG channels (Group1 and Group2), (b) absolute wavelength accuracy of Group1 (black stem), and (c) absolute wavelength accuracy of Group2 (black stem).

The performance of on-chip FBG interrogators is summarized in Table 2. Compared with the previous reports, it can be seen that our interrogator is the only one that provides the sub-picometer wavelength accuracy in a large wavelength range. Furthermore, it enables continuous wavelength interrogation and also works for multiple FBG sensors. Thanks to the optimized waveguide design

of the AWG, the chip loss is less than 5 dB. The ultra-compact high precision interrogator provides a very promising approach for the miniaturized fiber optic sensing system, such as aerospace, unmanned aerial vehicle monitoring, lithium-ion battery status monitoring, and 3D shape sensing in robot and medical fields.

Table 2 On-chip FBG interrogators.

Authors	Wavelength accuracy (pm)	Wavelength range (nm)	Continuous interrogation	Chip loss (dBm)	Dimension (mm)	Process platform
A. EDGAR <i>et al.</i> (2011) [29]	5	50	No	NA	50 × 18.5	SiO ₂
H.-M. MOON <i>et al.</i> (2019) [27]	7	38	No	NA	NA	SiO ₂
J. MEYER <i>et al.</i> (2019) [14]	75.9	2	No	NA	9.0 × 5.0	Polymer
L. CALETA <i>et al.</i> (2014) [31]	2	38.4	Yes	NA	NA	InP
D. PUSTAKHOD <i>et al.</i> (2016) [34]	NA	10	No	~6	2.5 × 2.5	InP
A. KAŹMIERCZAK <i>et al.</i> (2018) [30]	NA	9.6	No	NA	6.0 × 4.0	InP
A. TRITA (2015) <i>et al.</i> [28]	2.5	50	Yes	~6	2.2 × 1.5	Silicon
H. Q. LI (2017) <i>et al.</i> [33]	10	5	No	~6	5.0 × 3.0	Silicon
S. M. WENG (2022) <i>et al.</i> [32]	20.6	12	No	~6.35	0.3 × 0.3	Silicon
Our work (2022)	0.73	24	Yes	~4.3	2.0 × 0.5	Silicon

4. Conclusions

In summary, we present an on-chip interrogator based on the specially designed 1×16 AWG with the footprint of only 0.5×2.0 mm² on the SOI platform. The AWG is optimized with a large 3-dB bandwidth and low noise level, which enables FBG reflection peaks to be detected by multiple output channels using the CoG algorithm and consecutive curve fitting. To the best of our knowledge, the proposed on-chip interrogator has the highest wavelength accuracy (RMSE = 0.73 pm), compared with all AWG-based on-chip interrogators from previous literature at home and abroad. The on-chip interrogator enables continuous wavelength interrogation from 1544 nm to 1568 nm. The proposed on-chip interrogator, having the advantages of high wavelength accuracy, continuous wavelength interrogation, and the ultra-compact size, is very promising for applications in miniaturized fiber optic sensing systems (e.g., electric vehicles, airplanes, and aerospace). In the future work, we intend to increase the number of AWG channels or add the optical switch array on the chip to interrogate more FBG sensors. We will also estimate the sampling speed per channel of the interrogator chip and integrate the broad spectrum light source and photodetector array into the same chip.

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Declarations

Conflict of Interest Qing Yang is an editorial board member for Photonic Sensors and was not involved in the editorial review, or the decision to publish this article. All authors declare that there are no competing interests.

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